

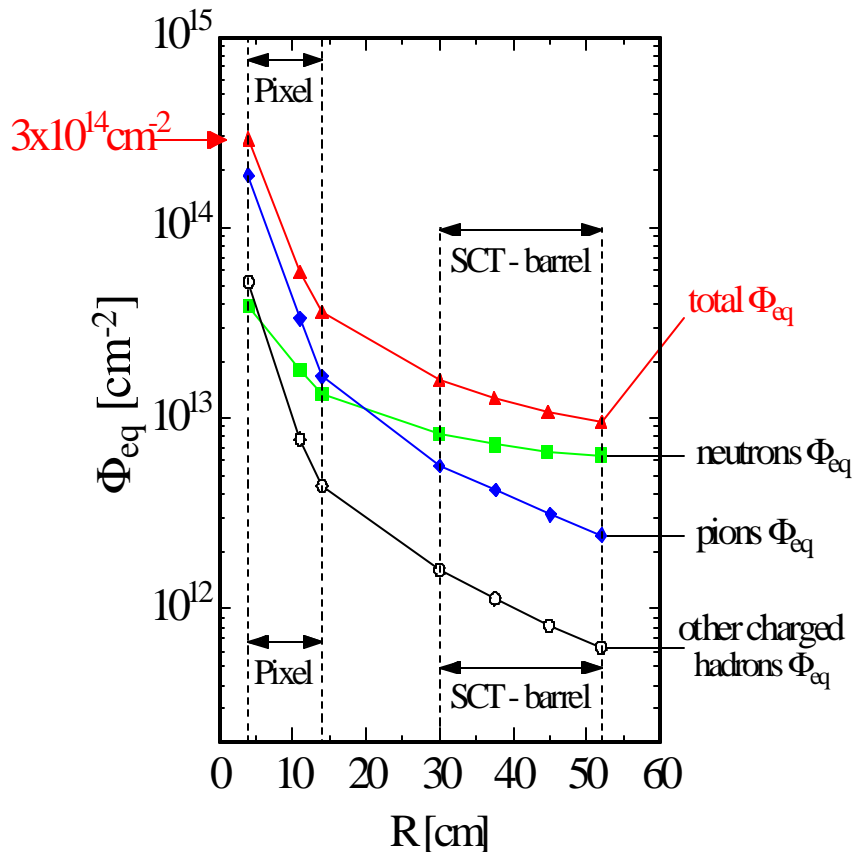
Isochronal Annealing Studies of Irradiated Silicon Diodes

Beverley Craig (EP-TA1-SD)
Summer Student Project

Contents

- Why Radiation Tests?
- Radiation Damage
- Isochronal Annealing
- Material and Experimental Procedure
- Results
- Conclusions

Motivation

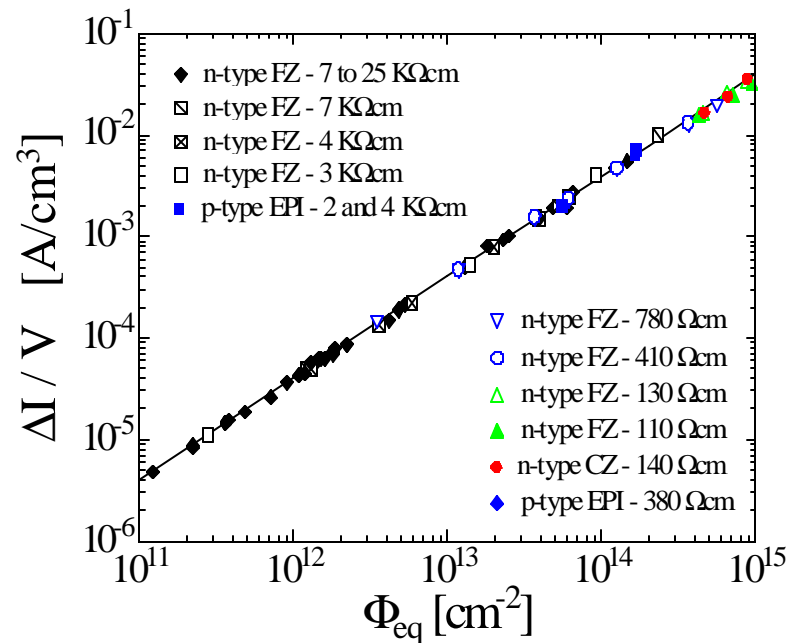


- Detectors will be harshly irradiated
- Φ_{eq} up to 3×10^{14} cm⁻² per year
- required 10 years of useful operation

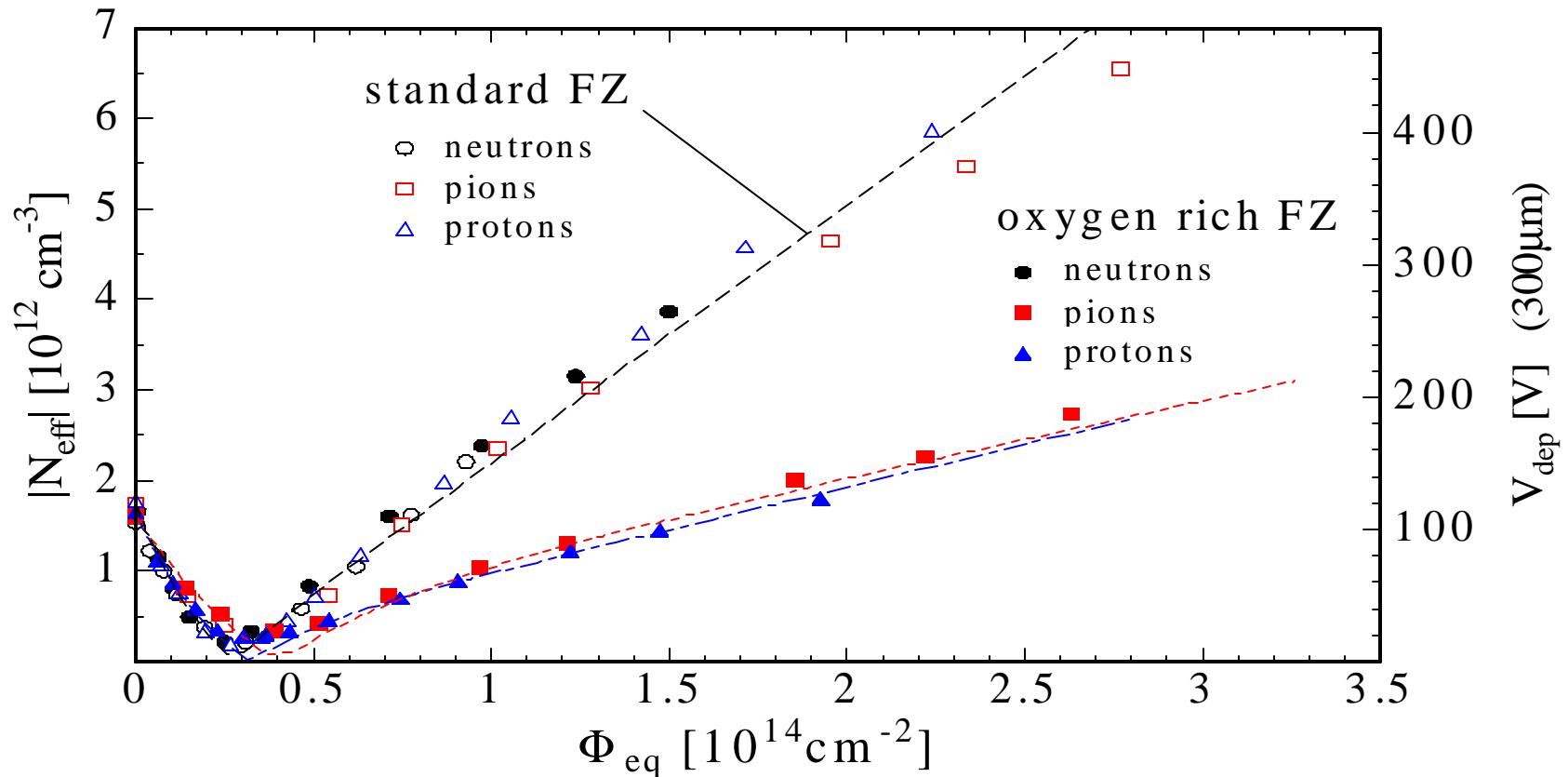
- Detector Characteristics affected by radiation:

- Leakage Current
- Depletion Voltage
- Charge Collection Efficiency

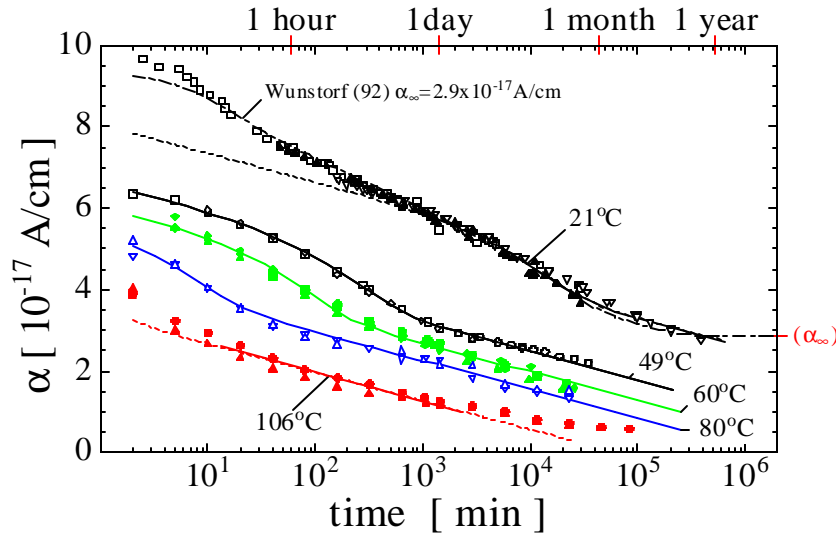
Leakage current $V_s \Phi_{eq}$



Standard and Oxygen Enriched Silicon – particle dependence

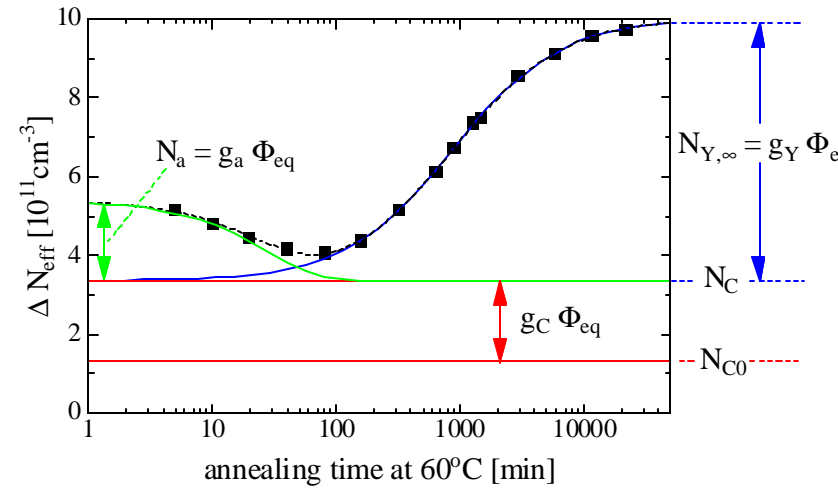


Leakage Current Annealing



$$I = \alpha V \Phi$$

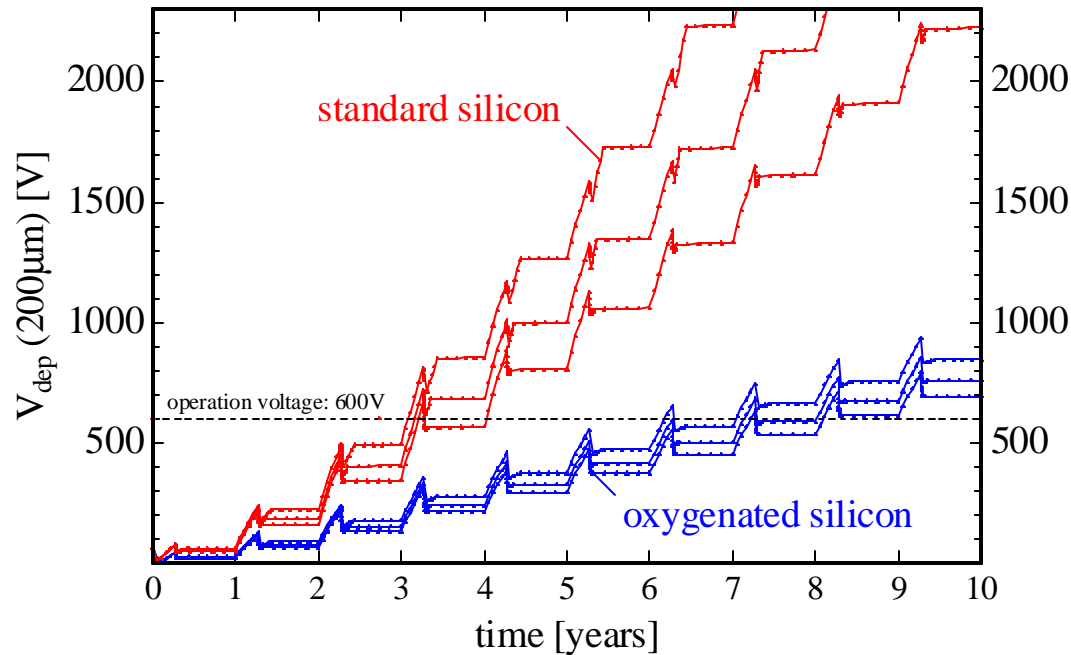
Depletion Voltage Annealing



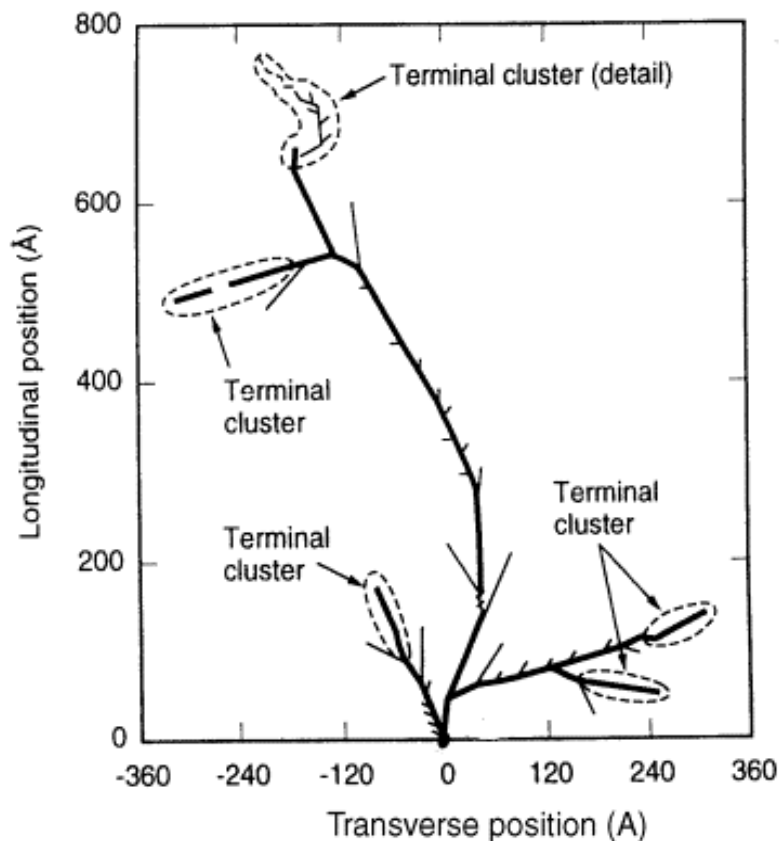
$$N_{\text{eff}} \propto \frac{V_{\text{dep}}}{d^2}$$

Damage Projection - ATLAS Pixel Detector - B-Layer (4cm)

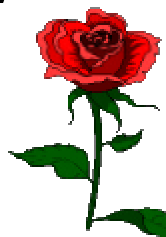
- Radiation level: ■ $\Phi_{eq}(\text{year}) = 3.5 \times 10^{14} \text{ cm}^{-2}$ (**full luminosity**)
> 85% charged hadrons
- Three scenario: ■ 1 year = 100 days beam (-7°C)
 - (1) 3 days 20°C and 14 days 17°C
 - (2) 30 days 20°C
 - (3) 60 days 20°CRest of the year: no beam (-7°C)



Radiation Damage

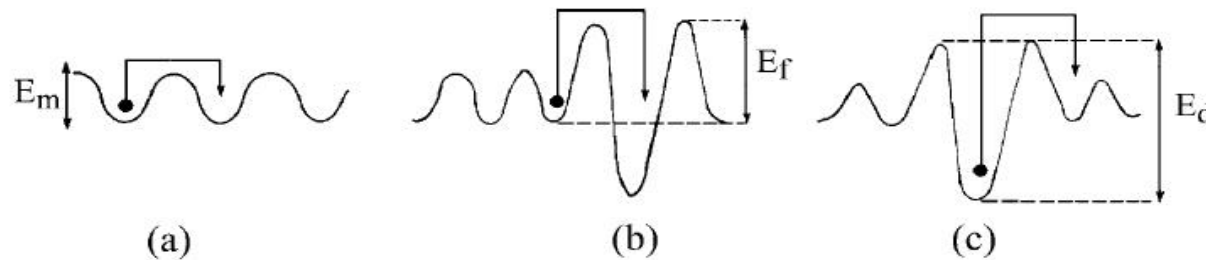


- Monte carlo Simulation of 50KeV PKA, from former ROSE collaboration (RD48)
- New RD50 project
- NI EL (Non Ionizing Energy Loss)



Isochronal Annealing

- 3 mechanisms
 - a) migration
 - b) complex formation
 - c) dissociation

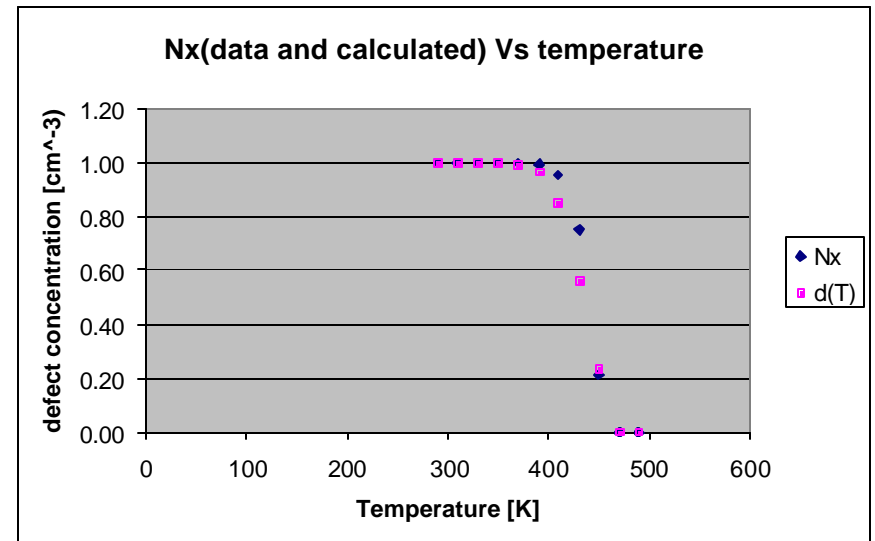


Annealing Follows exponential decay: $N_d \propto N_{d0} \cdot \exp\left(\frac{-t}{\tau}\right)$

where $\tau = \frac{1}{k} \exp\left(\frac{E_A}{k_b T}\right)$

Simulation

- Annealing Temperature :- defect concentration falls below 1/e-th part of the initial concentration
- Extract E_A



Experimental procedure

- Detectors provided by Hamburg group
- Irradiations at CERN PS (20GeV/c protons) and PSI (300MeV/c Π^+)
- Characteristics were taken for each detector after annealing for 15 minutes, over the range 20°C to 280°C in 20°C steps.
- Plots were produced for each measurement. From these, temperature plots were constructed and comparisons made.

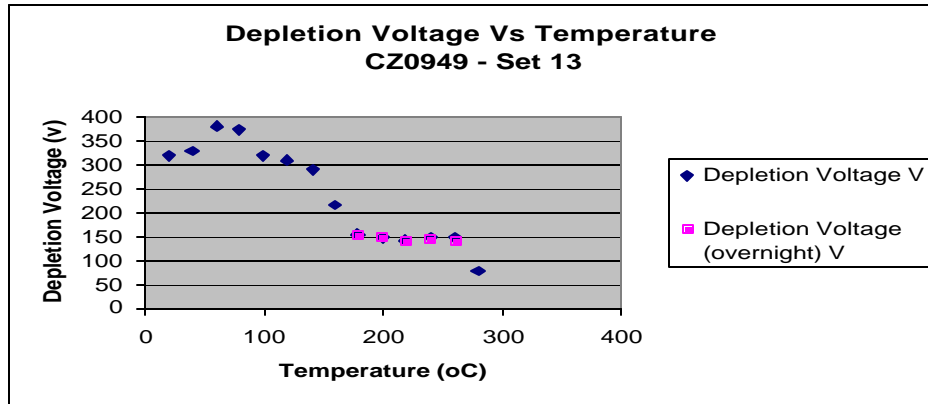
Detector Materials

Detector Name	Detector Type	Resistivity
CA09	Standard float zone silicon	4.2k Ω cm
CB08	DOFZ (24hr oxygenated)	3.6k Ω cm
CC11	DOFZ (48hr oxygenated)	4k Ω cm
CD19	DOFZ (72hr oxygenated)	3.37k Ω cm
CZ07/CZ08	Czochralski thermal donor killed	1.2k Ω cm
CZ09	Czochralski thermal donor generated	1.2k Ω cm

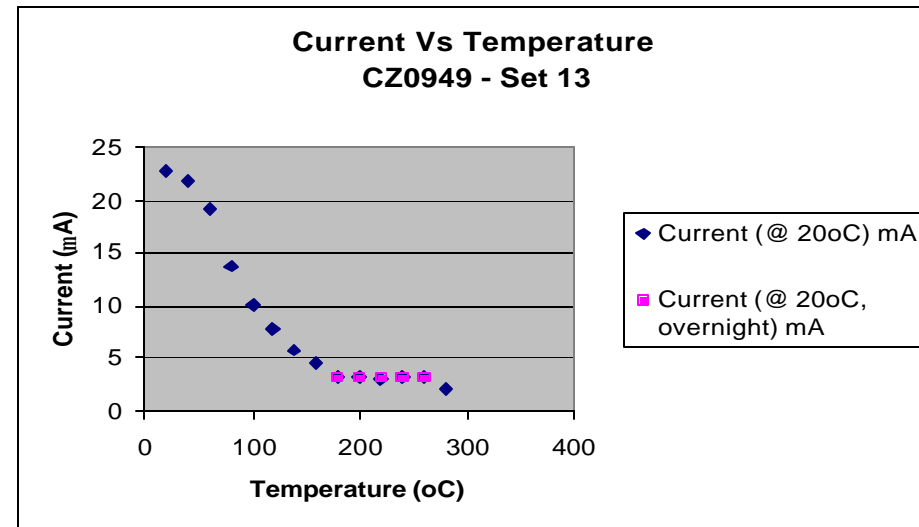
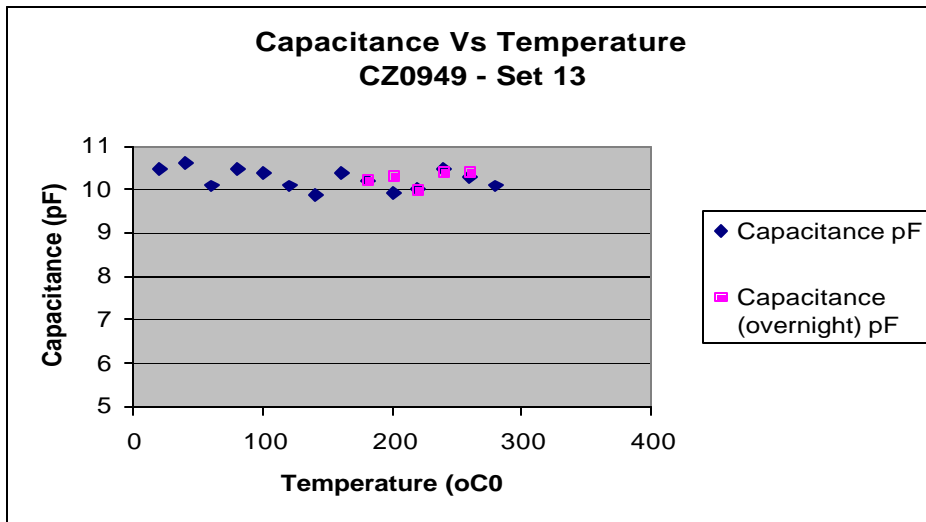
Irradiation

Set	Irradiating Particle	Fluence achieved [cm⁻²]
12 [FZ, 3xDOFZ, CZ-TD, CZ-TDK]	300MeV/c pions	9.33e13
13 [FZ, 3xDOFZ, CZ-TD, CZ-TDK]	300MeV/c pions	4.18e13
190 [CZ-TD, CZ-TDK]	20 GeV/c protons	9.08e13
195 [CZ-TD, CZ-TDK]	20 GeV/c protons	3.95e13
197 [FZ, 3xDOFZ,]	20 GeV/c protons	5.23e13
198 [FZ, 3xDOFZ,]	20 GeV/c protons	9.15e13

Isochronal Annealing of Irradiated Detector (1)

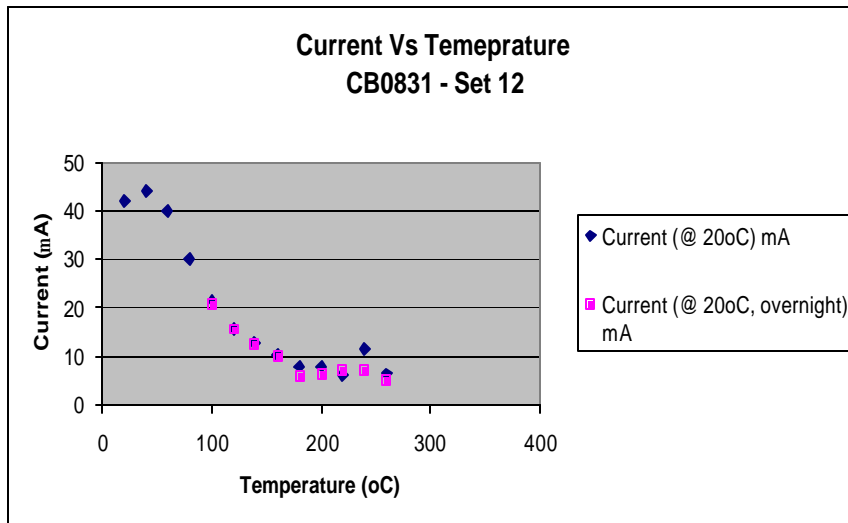
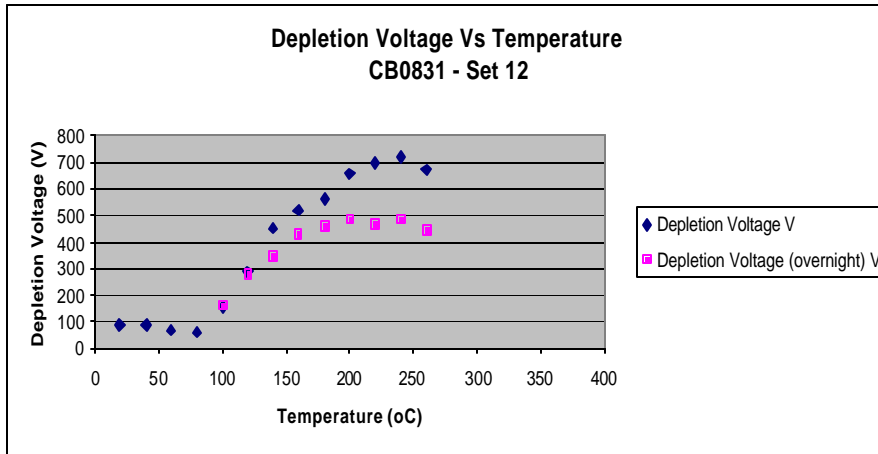


Example of a
Czochralski diode

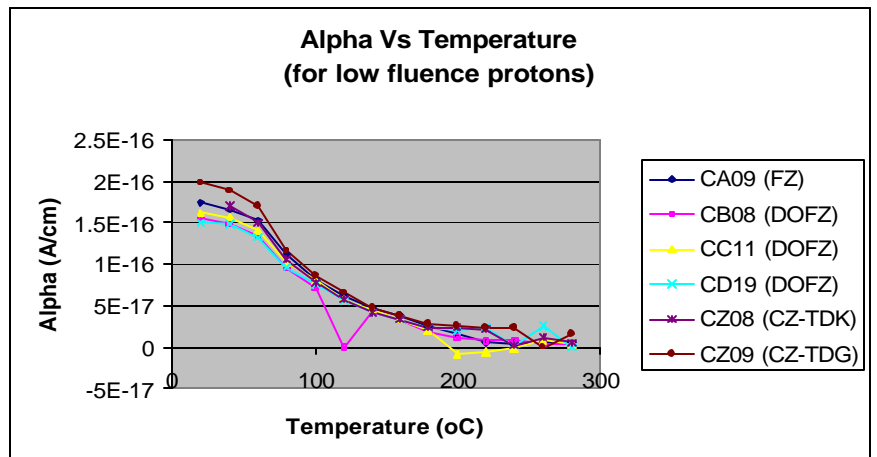
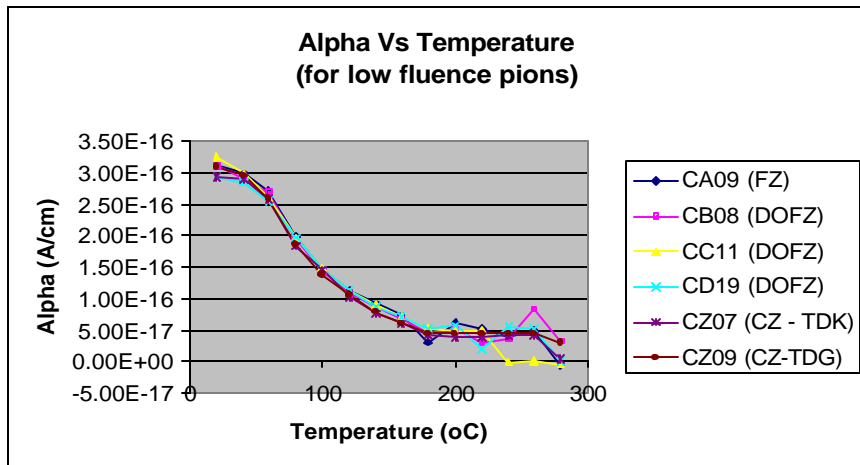
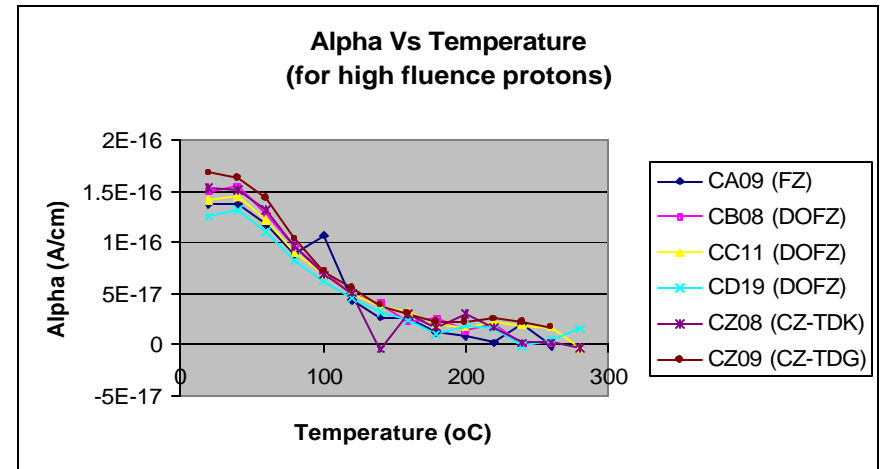
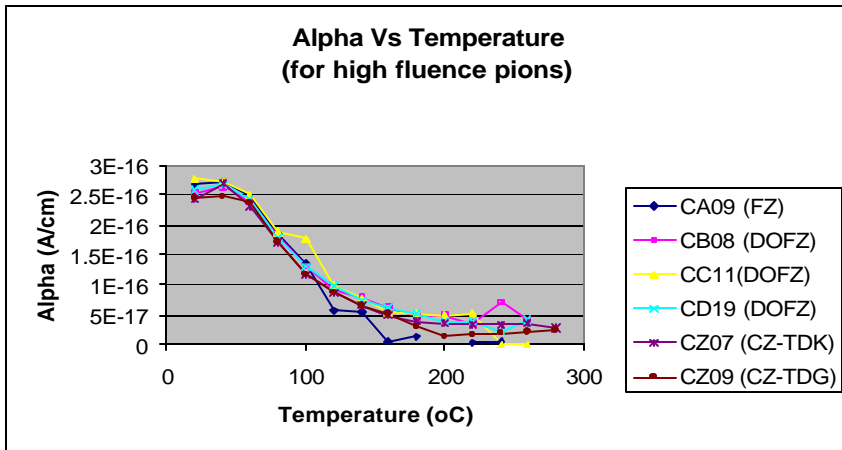


Isochronal Annealing of Irradiated Detector (1)

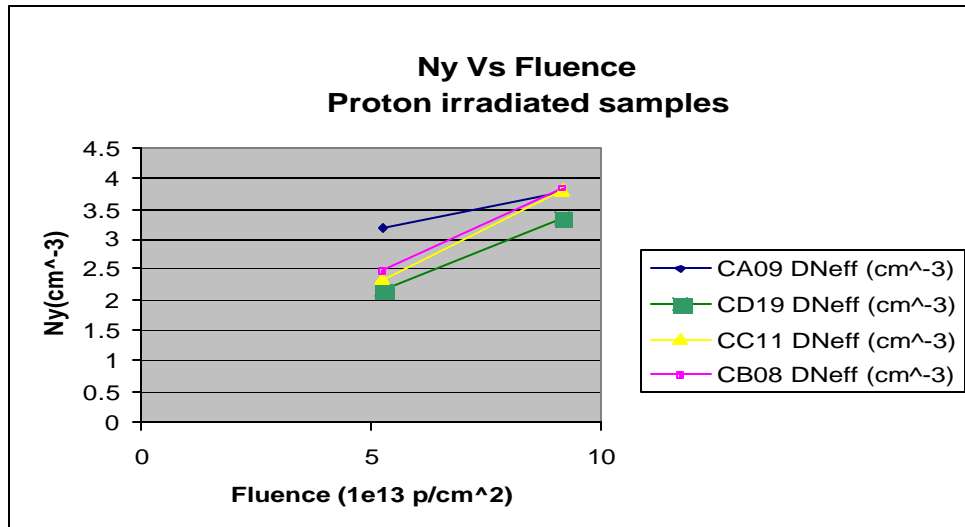
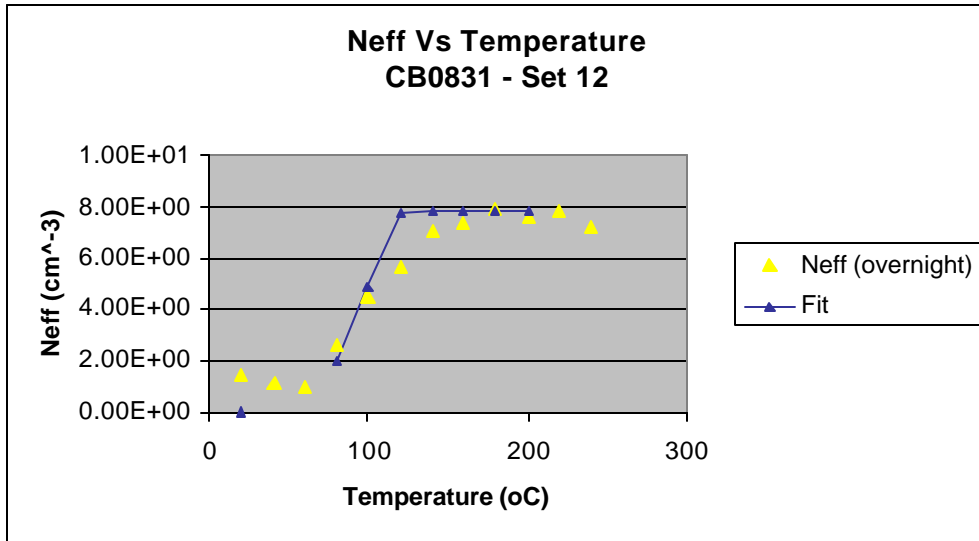
Example of a DOFZ diode
(24hr oxygenated)



a variation with temperature ($I=aVF$)



Neff Variation



	fluence (1e13/cm ²)	DNeff/F
Protons (low)		
CA09 (FZ)	5.23	0.606119
CB08 (DOFZ)	5.23	0.474187
CC11 (DOFZ)	5.23	0.449331
CD19 (DOFZ)	5.23	0.414914
CZ08 (CZ-TDK)	3.95	-0.66329
CZ09 (CZ-TDG)	3.95	-0.8481
Protons (high)		
CA09 (FZ)	9.15	0.414208
CB08 (DOFZ)	9.15	0.420765
CC11 (DOFZ)	9.15	0.417486
CD19 (DOFZ)	9.15	0.365027
CZ08 (CZ-TDK)	9.08	-0.28744
CZ09 (CZ-TDG)	9.08	-0.57819
Pions (low)		
CA09 (FZ)	4.18	1.043062
CB08 (DOFZ)	4.18	0.880383
CC11 (DOFZ)	4.18	0.901914
CD19 (DOFZ)	4.18	0.901914
CZ07 (CZ-TDK)	4.18	-0.63636
CZ09 (CZ-TDG)	4.18	-0.84928
Pions (high)		
CA09 (FZ)	9.33	0.734191
CB08 (DOFZ)	9.33	0.736334
CC11 (DOFZ)	9.33	0.708467
CD19 (DOFZ)	9.33	0.709539
CZ07 (CZ-TDK)	9.33	-0.25723
CZ09 (CZ-TDG)	9.33	-0.48124

Conclusions

- α was found to vary with fluence and temperature, but was independent of material – as expected from previous studies
- $\Delta N_{\text{eff}}/\Phi$ was lower for more oxygenated materials.
- $\Delta N_{\text{eff}}/\Phi$ is not constant -> Saturation effect.
- Depletion Voltage decreased for CZ material at higher temperatures, increased for both FZ and DOFZ. Cz is not type inverted.
- 'overnight effect' not observed for CZ N_{eff}
- 'overnight' effect not observed for α -> defect producing effect is not current producing.